IN THE COLETATES PATENT AND TRADEMARK OFFICE

In re application of

Shoriki NARITA et

Serial No. 09/988,704

Filed November 20, 2001

: Confirmation No. 9134

: Attorney Docket No. 2001_1718A

Group Art Unit 2625

Examiner Sheela Chawan

METHOD AND APPARATUS FOR CORRECTING INCLINATION OF IC ON SEMICONDUCTOR WAFER

ADDITIONAL CLAIMS FEE TRANSMITTAL LETTER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Transmitted herewith is an Amendment in the above-identified application. Additional fees required as a result of this Amendment are calculated as follows:

Indep. Claims exceeding 3 (not already paid for): 3 x	SMALL ENTITY		LARGE ENTITY
	(\$100 = \$)	or	(\$200 = \$600.00)
Total Additional Fee =	<u>\$</u>	or	<u>\$600.00</u>

[X] A check in the amount of \$600.00 is enclosed.

Respectfully submitted,

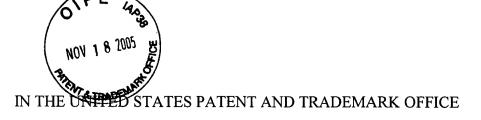
Shoriki NARITA et a

W. Douglas Hahm

Registration No. 44,142

Attorney for Applicants

WDH/ck Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 November 18, 2005



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Confirmation No. 9134

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AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Responsive to the Office Action dated July 27, 2005, the period for response to which having been extended by one-month to November 27, 2005, please amend the above-identified application as follows.

11/21/2005 JADDO1

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